

Notice of References Cited	Application/Control No. 10/722,907		Applicant(s)/Patent Under Reexamination TANADA ET AL.	
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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-2005/0270473	12-2005	Shiao et al.	349/158
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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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